Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3547	semiconductor and (gate adj stack)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/04 13:28
L2	3153	1 and (remov$4 or etch$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/04 13:28
L3	2077	2 and spacer	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/04 13:29
L4	1600	3 and implant$5	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/03/04 13:29